

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Stefan Marinca et al

Serial No.:

10/680,265

Confirmation No.:

6382

Filed:

October 7, 2003

For:

METHOD AND APPARATUS FOR COMPENSATING FOR TEMPERATURE DRIFT IN SEMICONDUCTOR

PROCESSES AND CIRCUITRY

Examiner:

Yelena Rossoshek

Art Unit:

2825

## MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Madam:

## **AMENDMENT ACCOMPANYING RCE**

In response to the Office Action mailed May 20, 2008, and pursuant to the Request for Continued Examination filed herewith, please amend the above-identified application as follows: Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this amendment.

Remarks begin on page 8 of this amendment.